



501.41125X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. HIROI, et al
Serial No.: 10/062,666
Filed: February 5, 2002
For: PATTERN INSPECTION METHOD AND SYSTEM THEREFOR
Group: 2881
Examiner: K. Fernandez

AMENDMENT

Mail Stop Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 23, 2003

Sir:

In response to the Office Action dated May 23, 2003, the following amendments and remarks are respectfully submitted in connection with the above-identified application, as listed below and as set forth on the following pages:

Amendments to the Claims; and

Remarks are included following the amendments.

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